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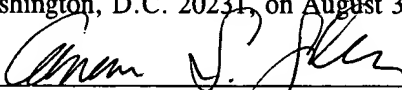
Docket: 0756-1961

12/13/01
8-10-00
C. Brown

**RESPONSE UNDER 37 CFR 1.116 - EXPEDITED
PROCEDURE - EXAMINING GROUP 2811**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on August 3, 2000.


Cameron S. Gilligan

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
In re PATENT application of)
Shunpei YAMAZAKI et al.) Group Art Unit: 2811
Serial No. 09/295,607) Examiner: S. Loke
Filed: April 22, 1999)
For: SEMICONDUCTOR DEVICE HAVING)
ALUMINUM NITRIDE FILM) Date: August 3, 2000

AMENDMENT AFTER FINAL

Assistant Commissioner for Patents
Box AF
Washington, D.C. 20231

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Sir:

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In response to the Office Action of April 3, 2000, please amend the above-identified application as follows.

IN THE SPECIFICATION:

Before the first sentence of the specification, please insert the following:

--This application is a Divisional of Application Serial No. 08/877,307, filed June 17, 1997, which is itself a Divisional of Application Serial No. 08/456,404, filed June 1, 1995, now U.S. Patent No. 5,650,636.--

Sub C'
B

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